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FACSIMILE TRANSMITTAL SHEET

TO: Commissioner for Patents

FIRM/COMPANY: U.S. Patent and Trademark Office

FACSIMILE NUMBER: (703) 746-9195

**CONFIRMATION
TELEPHONE:**

FROM: Richard A. Paikoff

DIRECT DIAL: 215.979.1853

DATE: November 19, 2004

USER NUMBER: 7094

FILE NUMBER: N1085-00131 – Serial No. 10/813,799

TOTAL # OF PAGES: 3
(INCLUDING COVERSHEET)

MESSAGE: Attached is a Request For Corrected Filing Receipt and a copy of the official Filing Receipt in re: Serial No. 10/813,799 filed 03/31/2004.

NOTE: Original will not follow

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PATENT

ATTORNEY DOCKET NO.: N1085-00131
[TSMC2002-0982]

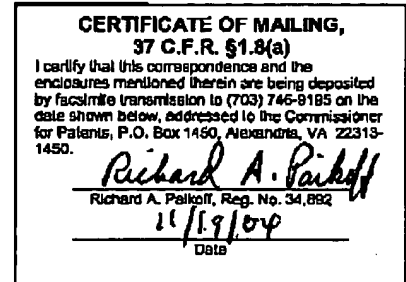
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Yi-Ling Chen**

Serial No.: 10/813,799

Examiner: Not Known Yet

Filed: 03/31/2004

Group Art Unit: 2877
Confirmation No. 7559For: **METHOD FOR IN SITU MONITORING OF
CHAMBER PEELING**REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Attached is a copy of the official Filing Receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested. There is only one inventor for this patent application whose name is Yi-Ling Chen (last inventor listed on the filing receipt). Please remove the four inventor names above his name.

A copy of the Filing Receipt is also attached with the foregoing error circled as found on the official Filing Receipt.

Respectfully submitted,

Date: 11/19/04

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/813,799	03/31/2004	2877	770	N1085-00131	3	16	2

CONFIRMATION NO. 7559

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FILING RECEIPT



OC000000012923597

Date Mailed: 06/10/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 06/10/2004

Projected Publication Date: 10/06/2005

Non-Publication Request: No

Early Publication Request: No

Title

Method for in situ monitoring of chamber peeling